

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1765



Applicant: Karola Richter et al.

Serial No: 10/553,728

Filing Date: October 14, 2005

Title: SILICON SUBSTRATE COMPRISING POSITIVE ETCHING  
PROFILES WITH A DEFINED SLOPE ANGLE AND PRODUCTION METHOD

Examiner: Duy Vu Nguyen

Att Unit: 1765

July 2, 2007

Attorney's Docket No.: HMP201T1

**TRANSMITTAL LETTER**

Hon. Commissioner of Patents and Trademarks  
P.O. Box 1450, Alexandria, VA 22313

SIR:

Transmitted herewith for filing:

AMENDMENT dated June 21, 2007 (16 pages)

(X) The applicant hereby petitions the Commissioner of Patents and Trademarks to extend the time for response to any Office Action outstanding in the above captioned matter as necessary to avoid abandonment of the application. Please charge my deposit account No.11-0224 in the amount required to cover the cost of the extension. Any deficiency or overpayment should be charged or credited to the above account.

(X) The Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16, and 1.17, after a mailing of a Notice of Allowance under 37 CFR 1.18 or any additional fees which may be required during the entire pendency of the application, or credit any overpayment, to Acct. No.11-0224. A duplicate copy of this sheet is enclosed. If and only if account funds should be insufficient, immediately contact our associate, Lisa Zumwalt, at (703)415-0579, who will pay immediately to avoid deprivation of rights.

( ) Please charge my Deposit Account No.11-0224 in the amount of \$ \_\_\_\_\_. A duplicate copy of this sheet is enclosed. A signature or signatures required for the above recited document(s) is (are) provided herebelow. Such signature(s) also provide(s) ratification for any required signature appearing to be defective in the above recited document(s).

*Horst Kasper*

Horst Kasper, 13 Forest Drive, Warren, N.J.07059  
Reg. No. 28,559 Tel.(908)526-1717

CERTIFICATE OF MAILING:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to the Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313, on JUL 02 2007

Signature: *Horst Kasper*

Date: JUL 02 2007

\*%Pci1:d:trans1(HMP201T1(July 2, 2007(am



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Karola Richter et al.

Serial No: 10/553,728

Art Unit: 1765

Filing Date: October 14, 2005

Title: SILICON SUBSTRATE COMPRISING POSITIVE  
ETCHING PROFILES WITH A DEFINED SLOPE ANGLE AND  
PRODUCTION METHOD

Examiner: Duy Vu Nguyen

---

June 21, 2007

Attorney's Docket No.: HMP201A1

**AMENDMENT**

Hon. Commissioner of Patents and Trademarks

P.O. Box 1450, Alexandria, VA 22313

SIR:

This is in response to the Office Action mailed on May 31, 2007, and setting a shortened statutory period for response of thirty days to expire on July 1, 2007. Applicants petition that, if required, the time for response be extended and the corresponding fee be charged. The Commissioner is hereby authorized to charge any additional fees which may be required to Acct. No. 11-0224. Applicants further respectfully request that this response be accepted as a bona fide effort to meet any potential response requirements outstanding and due in the above captioned matter.

Please amend the application as follows: